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Rabarot, et al.

SERIAL NO.:

09/601,382

FILING DATE:

September 21, 2000

TITLE:

METHOD FOR MAKING MICRORELIEFS, AND ESPECIALLY

MICROPRISMS BY MICRO-MACHINING AND TOOLS FOR

IMPLEMENTING THE METHOD

EXAMINER:

S. Blount

ART UNIT:

3726

CERTIFICATE OF MAILING

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REQUEST FOR CONTINUED EXAMINATION; PRELIMINARY RESPONSE AND AMENDMENT

In response to the Office Action dated February 13, 2002, please review the remarks regarding the above-mentioned application as follows.

RECEIVED

JUL 2 9 2002

TECHNOLOGY CENTER R3700